

S/N 09/945,553

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Fernando Gonzalez et al.	Examiner:	George Fourson
Serial No.:	09/945,553	Group Art Unit:	2823
Filed:	August 30, 2001	Docket No.:	303.775US1
Customer No.:	73115	Confirmation No.:	1842
Title:	METHOD TO CHEMICALLY REMOVE METAL IMPURITIES FROM POLYCIDAL GATE SIDEWALLS		

COMMUNICATION RE: FEE ADDRESS

Mail Stop Issue Fee
Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

In response to the Notice of Allowance and Issue Fee Due, please record the Fee Address under the provisions of 37 CFR 1.363 as the following:

Customer Number 26809

which is associated with Micron Technology, Inc..

Please direct any inquiries to the undersigned attorney at (612) 349-9587.

Respectfully submitted,

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Date

8 Feb '08

By

Timothy B. Clise
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TBC/cmb

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 8 day of February, 2008.

Name

Chris Egan

Signature

Chris Egan